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PATENT
81877.0012
Customer No. 26021

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Seiyo NAKASHIMA, et al.
Serial No: 09/816,643
Confirmation No: 6862
Filed: March 23, 2001
For: Substrate Processing Apparatus
and Substrate Processing Method

Art Unit: 1763

Examiner: Kackar, Ram N.

I hereby certify that this correspondence
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October 25, 2005

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Juanita Soberanis

Name *Juanita Soberanis* 10/25/2005
Signature Date

PETITION FOR EXTENSION OF TIME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the Commissioner for a five-month extension of time extending to October 25, 2005, from which a Notice of Appeal was filed on March 25, 2005 in response to the Final Office Action dated September 27, 2004. The extension is sought for the purpose of maintaining pendency so that a continuation application of this case may be filed. Please charge the fee of \$2,160 for this extension to Deposit Account No. 50-1314.

Please charge any insufficiency or credit any overpayment to Deposit Account No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: October 25, 2005

By: *Lawrence J. McClure*
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